



Attorney Docket No. 0492611-0543/MIT-9277CON1

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

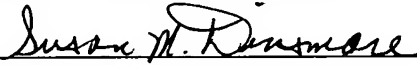
Applicant: Seleznev, et al. Examiner: To be assigned  
Serial No.: 10/799,436 Art Unit: 1751  
Filing Date: March 12, 2004

Title: VACUUM PROCESSING FOR FABRICATION OF  
SUPERCONDUCTING THIN FILMS FABRICATED BY METAL-  
ORGANIC PROCESSING

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450  
Sir:

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450, on September 28, 2004.

  
Susan M. Dinsmore

**PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. 1.136**

A two (2) month extension of time, from August 1, 2004 to and including October 1, 2004 is requested to file a Response to Notice to File Missing Parts in the above-referenced application. The large entity extension fee of \$420.00 is enclosed herewith.

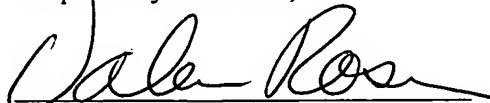
Please charge any fees associated with this filing, or apply any credits, to our Deposit Account No. 03-1721.

10/01/2004 HALI11 00000059 10799436

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420.00 OP

Respectfully submitted,

  
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Dated: September 28, 2004